



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/798,653  
Applicant: Edmond BAILLOT, et al.  
Filed: March 11, 2004  
Title: Plasma cutting process with dual gas flow  
TC/A.U. 3742  
Examiner: Unknown  
Docket No.: Serie 6150  
Customer No.: 000040582

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner of Patents  
P.O. Box 1450  
Washington, D.C. 20231


Dear Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited on the enclosed PTO Form 1449 is enclosed.

No fee is due at this time in accordance with 37 C.F.R. § 1.97. However, the Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 01-1375. This paper is submitted in duplicate.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

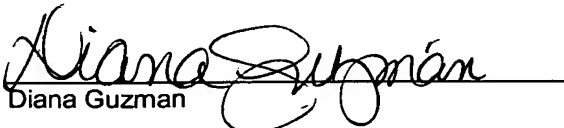
  
Elwood Haynes, Reg. No. 55,254

Date: June 17, 2004

Air Liquide  
Intellectual Property Department  
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**CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17<sup>th</sup> day of June, 2004.

  
Diana Guzman

